

8-1-3

(2-92)

Sheet 1 of 3

Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>		Docket Number (Optional) <b>3375.9US (95-0999.08/US)</b>		Application Number <b>Not yet assigned</b>	
Applicant <b>Donald L. Yates</b>		Filing Date <b>August 1, 2003</b>		Group Art Unit <b>Unknown</b>	

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JHS	4,132,567	01/1979	Blackwood	X	X	
	4,197,000	04/1980	Blackwood			
	4,286,541	09/1981	Blackwood			
	4,635,666	01/1987	Daley et al.			
	4,682,615	07/1987	Burkman et al.			
	4,911,761	03/1990	McConnell et al.			
	4,984,597	01/1991	McConnell et al.			
	4,997,490	03/1991	Vetter et al.			
	5,069,235	12/1991	Vetter et al.			
	5,095,927	03/1992	Thompson et al.			
JHS	5,115,576	05/1992	Roberson, Jr. et al.			

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
JHS	0,385,536	05/1990	EP	X	X		
	61-154130	07/1986	Japan				
	4-99025	03/1992	Japan				
	4-152525	05/1992	Japan				
JHS	4-253332	09/1992	Japan				

  

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
JHS		Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15.
JHS		Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press. pp. 235-43.
JHS		Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55.

  

EXAMINER		DATE CONSIDERED	1/11/05
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance with MPEP § 609. Include copy of this form with next communication to the applicant.

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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JHS	5,186,192	02/1993	Netsu et al.	X	X	
	5,328,867	07/1994	Chien et al.			
	5,371,950	12/1994	Schumacher			
	5,520,744	05/1996	Fujikawa et al.			
	5,556,479	09/1996	Bran			
	5,653,045	08/1997	Ferrell			
	5,660,642	08/1997	Britten			
	5,681,397	10/1997	Li			
	5,714,203	02/1998	Schellenberger et al.			
	5,727,578	03/1998	Matthews			
	5,752,532	05/1998	Schwenkler			
	JHS	5,845,660	12/1998			Shindo et al.

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
JHS	4-354128	12/1992	Japan	X	X		
	5-47734	02/1993	Japan				

  

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
JHS		Leenaars et al., <i>Marangoni Drying: A New Extremely Clean Drying Process</i> , Langmuir, Vol. 6, No. 11, pp. 1701-03.
JHS		Wong et al., "Post-Acid Rinse Enhancement Through Megasonic Quickdump Rinsing", February 1997, pps. 1-7.

  

EXAMINER <div style="text-align: center; font-size: 1.5em;">JHS</div>	DATE CONSIDERED <div style="text-align: center; font-size: 1.5em;">1/11/05</div>
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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JHS	5,934,299	08/1999	Akatsu et al.	X	X	
	5,951,779	09/1999	Koyanagi et al.			
	5,958,146	09/1999	Mohindra et al.			
	6,001,191	12/1999	Kamikawa et al.			
	6,125,863	10/2000	Bexten			
	6,138,690	10/2000	Nakatani			
6,350,322	02/2002	Yates				
JHS	6,601,595	08/2003	Yates			

  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

  

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)

  

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